



PATENT APPLICATION *1R*

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Satoshi FURUTA  
Title: METHOD FOR MANUFACTURE OF ESTERS BY  
TRANSESTERIFICATION  
Serial No.: 10/558 935 Group: 1621  
Confirmation No.: 6397  
Filed: December 1, 2005 Examiner: Katakam  
International Application No.: PCT/JP2004/009250  
International Filing Date: June 23, 2004  
Atty. Docket No.: 4700.P0320US

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FIRST CLASS MAILING CERTIFICATE**

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 11, 2007.

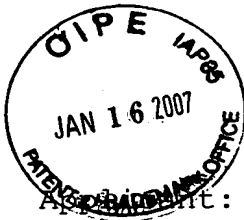
  
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	Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Information Disclosure Statement  
dated January 11, 2007  
including enclosures listed thereon

190.05/05



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### INFORMATION DISCLOSURE STATEMENT

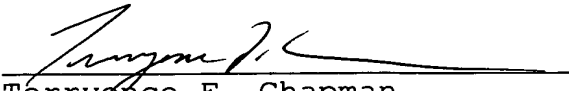
Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of the European Patent Office Search Report, Form PTO-1449 and the references cited thereon. The relevance of these references is explained on the enclosed search report. Accordingly, further comment at this point in time should not be necessary.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Further consideration is respectfully solicited.

Respectfully submitted,

  
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Encl: Copy of European Patent Office Search Report  
dated October 19, 2006 (3 pages)  
Form PTO-1449 and references cited thereon  
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INFORMATION  
DISCLOSURE  
CITATION  
JAN 16 2007  
U.S. PATENT AND TRADEMARK OFFICE

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## U.S. PATENT DOCUMENTS

Examiner Initials*	No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA	6 090 959	07-18-2000	HIRANO et al
	AB			
	AC			
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	AE			
	AF			
	AG			
	AH			
	AI			
	AJ			
	AK			

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AL	EP 1 505 048 A1	02-09-2005	LACOME et al	
	AM				
	AN				
	AO				
	AP				

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	
	AR	
EXAMINER SIGNATURE		DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.